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RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2863  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q64673

Teruji IKEMATSU

Appln. No.: 09/917,880

Group Art Unit: 2863

Confirmation No.: 2071

Examiner: Michael P. Nghiem

Filed: July 31, 2001

For: METHOD FOR CONTROLLING EXPOSURE AND SCAN-EXPOSURE APPARATUS

**RESPONSE UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 26, 2004, please consider the remarks as submitted herewith on the accompanying pages.

**REMARKS**

This Response, submitted in reply to the Office Action dated April 28, 2004, is believed to be fully responsive to each point of rejection raised therein. Accordingly, favorable reconsideration on the merits is respectfully requested.

As an initial matter, Applicant would note that the Examiner's Statement on Reasons for Allowance represents a paraphrase of the subject matter recited in the claims. Applicant would note that not all the claims deemed allowable include the explicit requirements set forth in the Statement for Allowance.